



IFW

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Nobuko OKADA et al.

Group Art Unit: 1762

Application No.: 10/617,747

Examiner: J. LIN

Filed: July 14, 2003

Docket No.: 109100.01

For: THIN FILM FORMATION METHOD BY INK JET METHOD, INK JET APPARATUS, PRODUCTION METHOD OF ORGANIC EL DEVICE, AND ORGANIC EL DEVICE

**AMENDMENT UNDER 37 C.F.R. §1.114**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the May 2, 2007 Office Action, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**